

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Rule 53(b) Divisional of  
Application No.: 09/857,803

Filed: October 15, 2003

Docket No.: 109725.01

For: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification; and**

**Remarks.**